JC20 F PCT/PTO 11 MAY 2009, 1

94326

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Pate	n Re U.S. Patent Application			
Applicant:	Takashi YOKOYAMA et al.)		
Serial No.:	Unassigned)		
Filed:	May 11, 2005)		
For:	SILICON WAFER, ITS MANUFACTURING METHOD,)		

INFORMATION DISCLOSURE STATEMENT

Mail Stop PCT Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313

Sir:

Pursuant to 37 C.F.R. §1.97, a list of documents is disclosed on the attached Form PTO-1449 that may be material to the examination of this application. The cited references are enclosed herewith.

Documents for which the supplied date of publication lists the year of publication without the month were published sufficiently earlier than the effective U.S. filing date and any foreign priority date, so that the particular month of publication is not in issue. Pursuant to §609 of the MPEP, it is understood that the month of publication is not required when the particular month of publication is not in issue.

No inferences should be drawn that the attached list represents a comprehensive investigation, or that any material disclosed is equivalent to the subject invention. In addition, none of the documents that have publication dates prior to the priority date of the above application anticipate the invention in this application.

Applicant also encloses a copy of the PCT Search Report and references cited therein.

The cited document(s) disclose numerous specific features. There has been no attempt to list each

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and every feature disclosed by each document. The Examiner is requested to review the document(s) and

determine the extent of the materiality of the document disclosures with respect to the present invention.

The discussion of any art and the citation of any document(s) herein is not to be construed as an

admission that the art or document disclosure is necessarily within the invention field of endeavor, that the

art or document disclosure is necessarily prior in time to a particular date which may be relevant to the

instant patent application, and/or that the art or document disclosure is otherwise necessarily prior art as

defined by the patent law with respect to the instant invention and application.

Also, there is reserved the right to later set forth how the instant invention is distinguished over the

disclosure of any document or other art, including the disclosures of the art and document(s) recited herein,

that may be cited by the Examiner in rejecting a claim in the instant patent application. The recitation

herein of the art and document(s) is not to be construed as an assertion that more pertinent art could not

possibly be in existence.

Respectfully submitted,

Gerald T. Shekleton

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Dated: May 11, 2005

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PTO/SB/08A & (04-03)
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INFORMATION DIGOLOGUES				Application Number	Inassidne 54946		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Filing Date	May 11, 2005 YOKOYAMA et al.		
			PLICANT	First Named Inventor			
(use as many sheets as necessary)				Art Unit	Unassigned		
			s necessary)	Examiner Name	Unassigned		
Sheet	1	of	1	Attorney Docket Number	94326		

	U.S. PATENT DOCUMENTS						
Examin er Initials*	Cite No.1	Document Number Number-Kind Code ^{2 (if known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear		
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T 6
		JP 2001-278692	10/10/2001	Ryoji et al.		Abstract
		JP 61-193456	08/27/1986	Kikuo et al.		Abstract
		JP 2001-102385	04/13/2001	Kazuhiro et al.		Abstract
		JP 3-279290	12/10/1991	Shinichi		Abstract

	NON PATENT LITERATURE DOCUMENTS				
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